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** CONTINUING DATA *****

None M

** FOREIGN APPLICATIONS *****

REPUBLIC OF KOREA 2003-12101 02/26/2003 M

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Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 4	TOTAL CLAIMS 15	INDEPENDENT CLAIMS 4
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged Examiner's Signature <i>[Signature]</i> Initials <i>M</i>				

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TITLE

Method for manufacturing polycrystalline silicon thin film and thin film transistor fabricated using polycrystalline silicon thin film
 manufactured by the manufacturing

FILING FEE

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FEES: Authority has been given in Paper
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